



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Applicant:

SECUNDO et al

Serial No.: 10/698,463

Filed: 03 Nov 2003

For: Thermal Imaging System and Method

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Group Art Unit: 2874

Attorney Docket No.: 3078/1

Examiner:

Commissioner of Patents and Trademarks  
Washington, D.C. 20231

INFORMATION DISCLOSURE STATEMENT


Sir:

Enclosed is PTO Form 1449 which lists citations which may be material to the patentability of the above-identified application.

Also enclosed are copies of the references cited. These are being submitted in compliance with the duty of disclosure defined in 37 C.F.R. 1.56. The Examiner is requested to make these citations of official record in this application.

This Information Disclosure Statement Under 37 C.F.R. 1.56 is not to be construed as a representation that a search has been made, that additional matter which is material to the examination of this application does not exist, or that any one or more of these citations constitutes prior art.

Respectfully submitted,

  
Mark M. Friedman  
Attorney for Applicant  
Registration No. 33,883  
Date: February 10, 2004

Sheet 1 of 1

Form PTO-1449 (Modified)

Atty. Docket No.  
3078/1Application No.  
10/698,463INFORMATION DISCLOSURE CITATION  
IN AN APPLICATION  
(USE SEVERAL SHEETS IF NECESSARY)Applicant:  
Secundo et alFiling Date:  
03 November 2003Group Art Unit:  
2874

## U.S. PATENT DOCUMENTS

	EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUB- CLASS	FILING DATE
AA							
AB							
AC							
AD							
AE							
AF							

## FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB-CLASS	TRANSLATION	
							YES	NO
AG								

## OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)

AH		"Handbook of Optics – Fundamentals Techniques and Design", Michael Bass, Eric W. Van Stryland, David R. Williams, William L. Wolfe (Editors), McGraw Hill 1995, (2 <sup>nd</sup> edition), Vol. 1 Chapters 15-19
AI		"Un-cooled Thermal Imaging: Arrays Systems, and Applications" by Paul W. Kruse, SPIE, 2001
AJ		"Introduction to Photorefractive Nonlinear Optics", by Pochi Yeh, Wiley & Sons, USA, 1993, pp. 26 - 29.
AK		

EXAMINER

DATE CONSIDERED

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformation and not considered. Include copy of this form with next communication to applicant.